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46/Amend  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
(Attorney Docket No. MIC-58DV2)

Inventor: Zhang et al. ) Examiner: Mohamedulla  
Serial No. 09/722,400 ) Art Unit: 1756  
Filing Date: November 27, 2000 )  
For: POLYIMIDE AS A MASK IN VAPOR HYDROGEN FLUORIDE  
ETCHING

CERTIFICATE UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence, and any enclosures referenced herein, is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450

on 7/18/2003.

Jody Begley

Assistant Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

In response to the Office Action of January 29, 2003, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.